



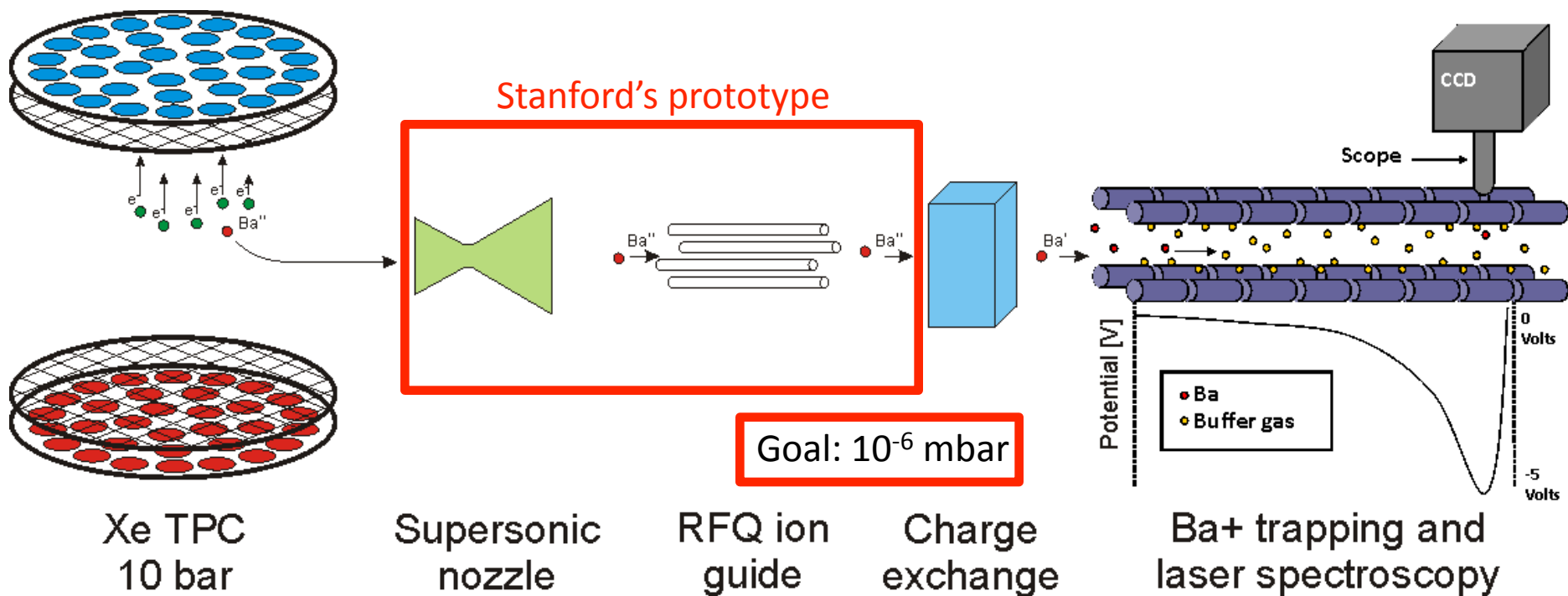
Ba Tagging in gXe at Stanford

EXO Week

Dec 10, 2013

Thomas Brunner, Dan Fudenberg
for the Gas Tagging Group

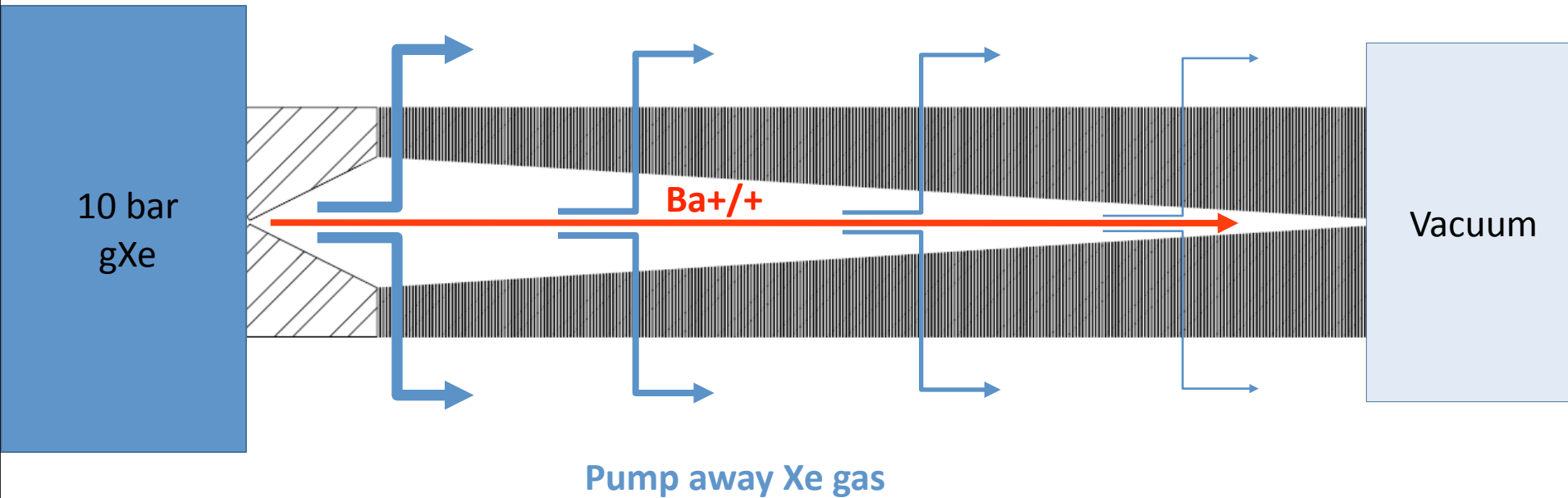
Tagging from Gas Xenon



The Plan:

- Extract Ba⁺⁺ from TPC by shaping E-field through a nozzle
- Guide into low pressure chamber then into a vacuum chamber
- Convert Ba⁺⁺ to Ba⁺ [1]
- Identify via laser spectroscopy [2]

RF-funnel concept: V. Varentsov



RF-funnel concept:

- Mounted on a converging-diverging nozzle with a 0.28 mm throat diameter
- 2 stacks totaling 301 electrodes with 0.010" spacing between adjacent electrodes
- RF-field applied to electrodes confines ions while gas flow pushes ions through
- $P_0 = 10 \text{ bar}$, $P_a = 1 \text{ mbar}$

$$V_{\text{RF}} = 120 \text{ V}$$

$$f = 10 \text{ MHz}$$

Simulated Ba^+ transmission
~95%

$$V_{\text{RF}} = 25 \text{ V}$$

$$f = 2.6 \text{ MHz}$$

Simulated Ba^+ transmission
~72%

gXe Tagging Setup

Xe bottles

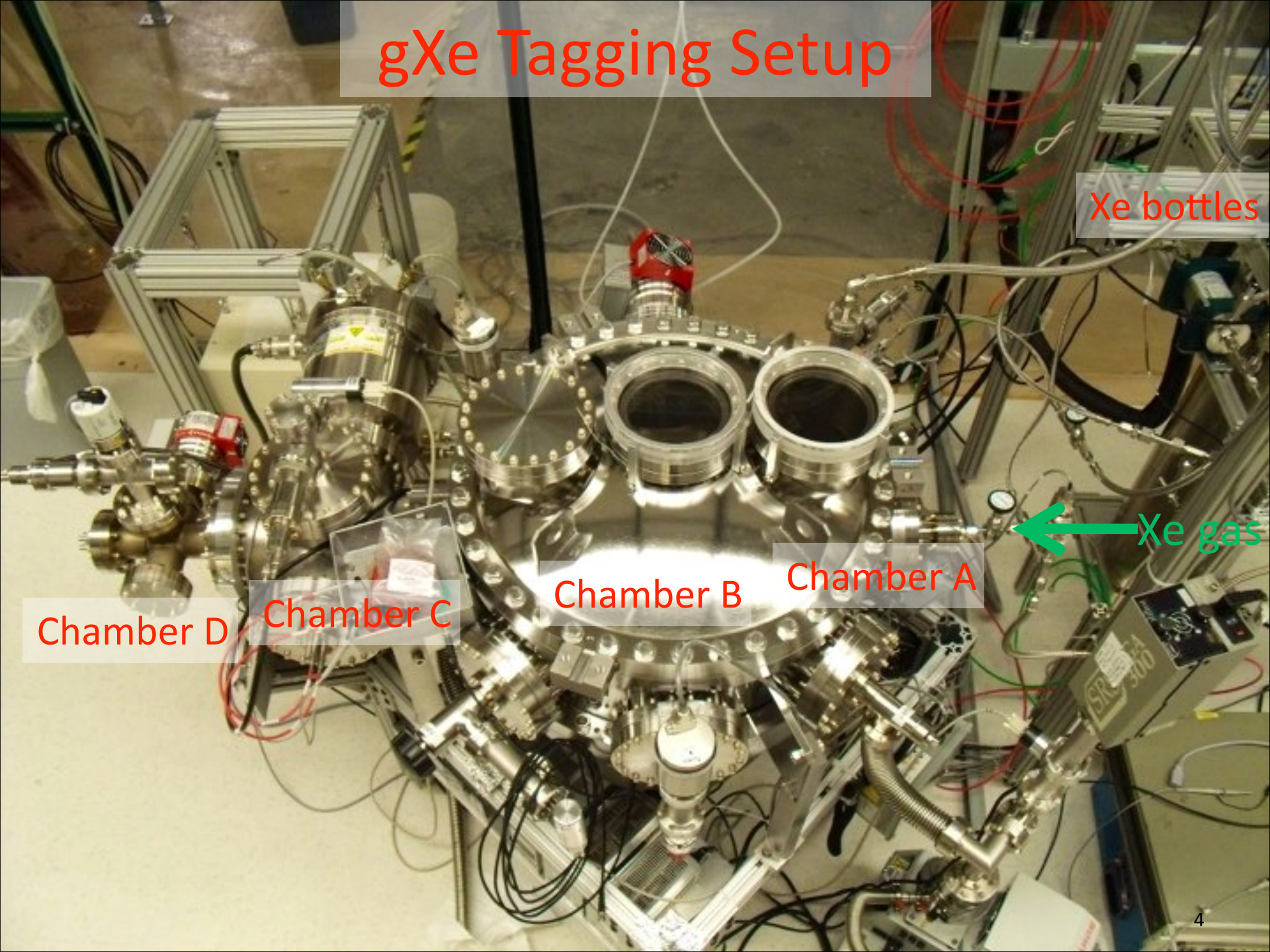
Xe gas

Chamber D

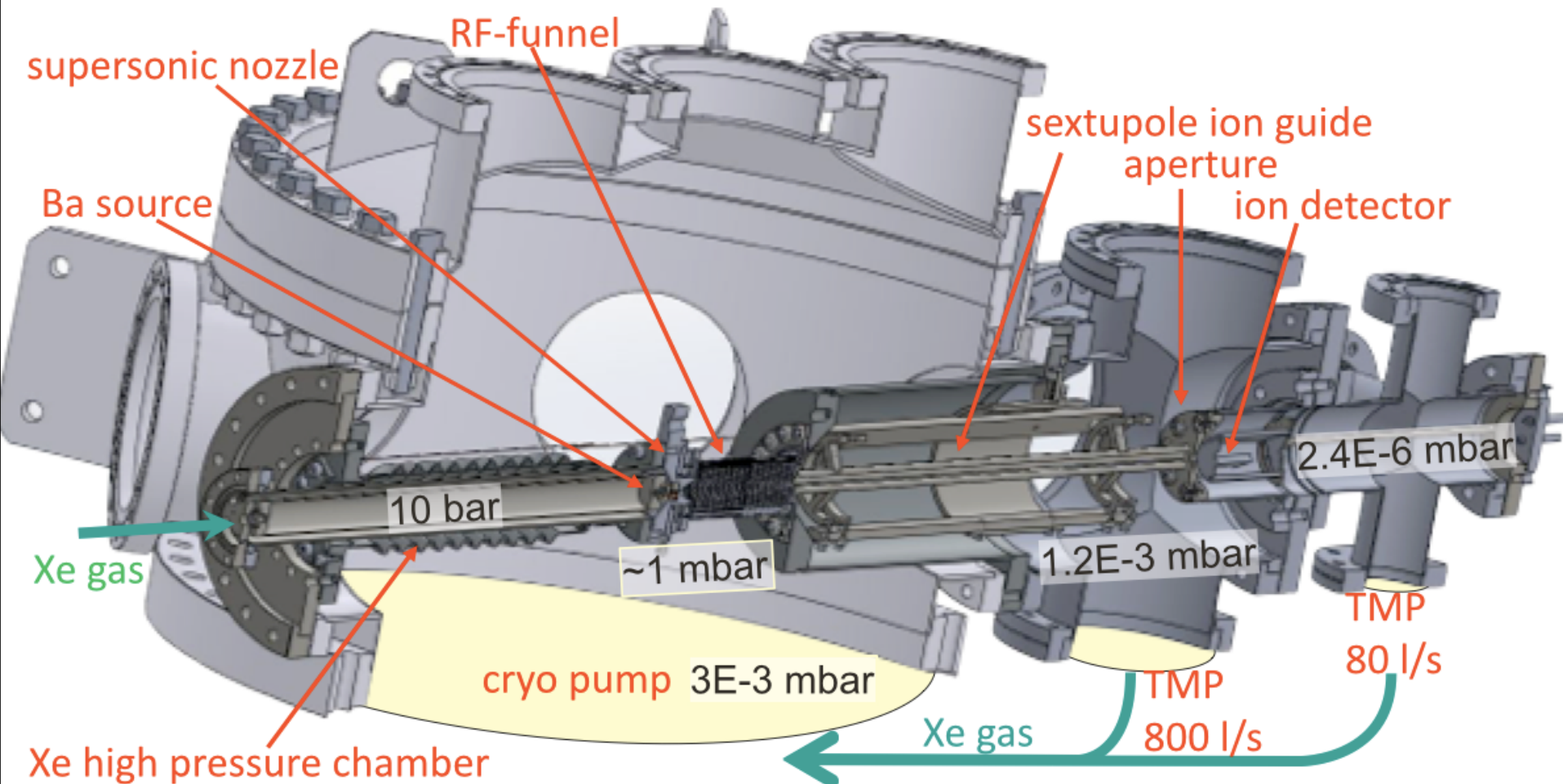
Chamber C

Chamber B

Chamber A



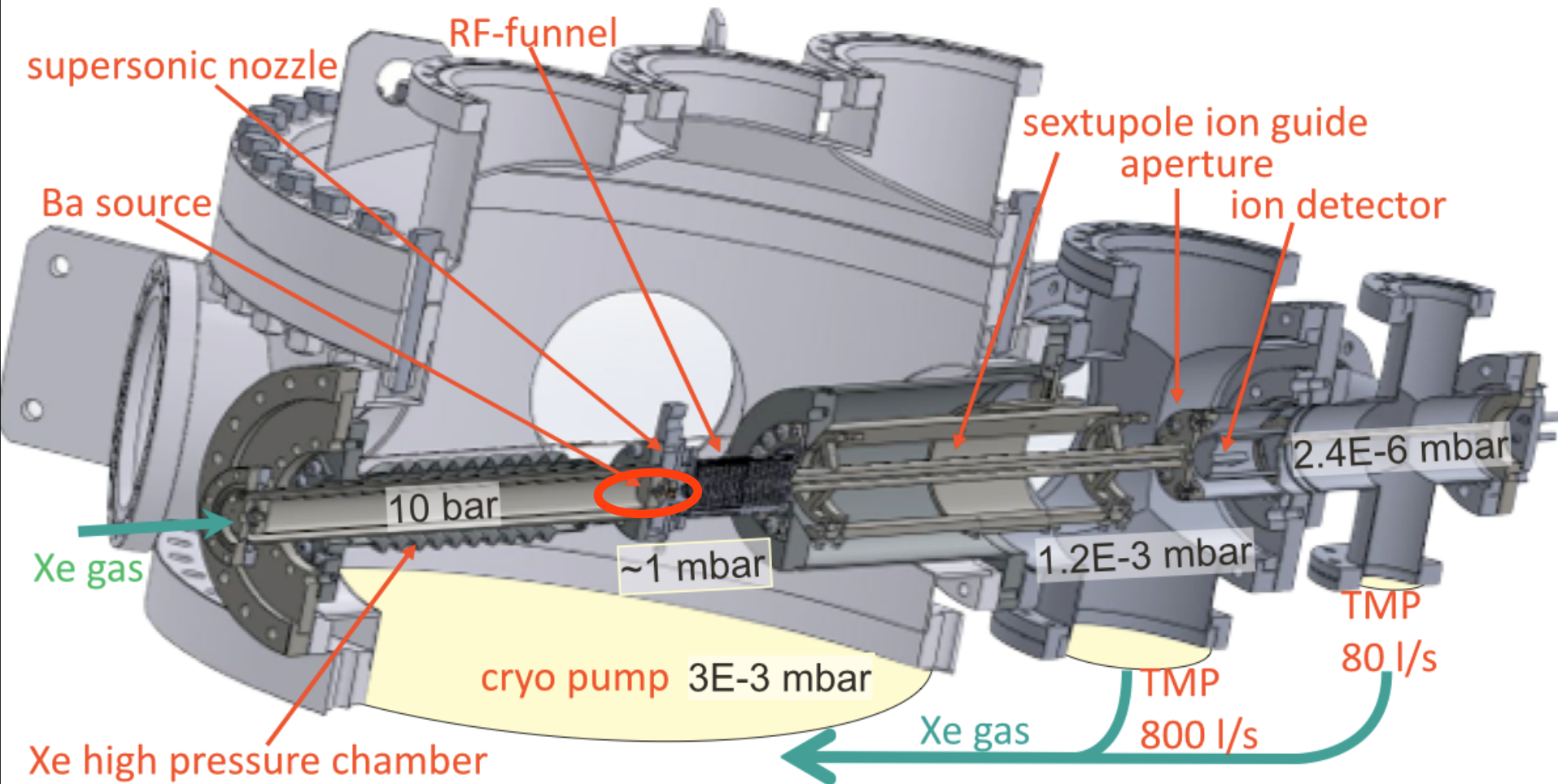
A Look Inside



Differential Pumping Stages

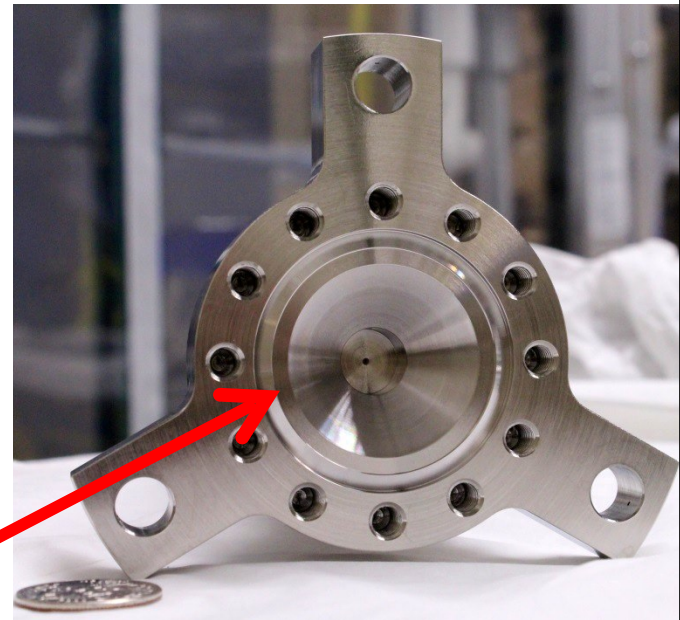
Chamber A	Funnel Interior	Chamber B	Chamber C	Chamber D
High pressure Xe	Funnel	Cryopump chamber	SPIG	Detection
10 bar	~1 mbar	3E-3 mbar	1.2E-3 mbar	2.4E-6 mbar

Ba Source and Holder



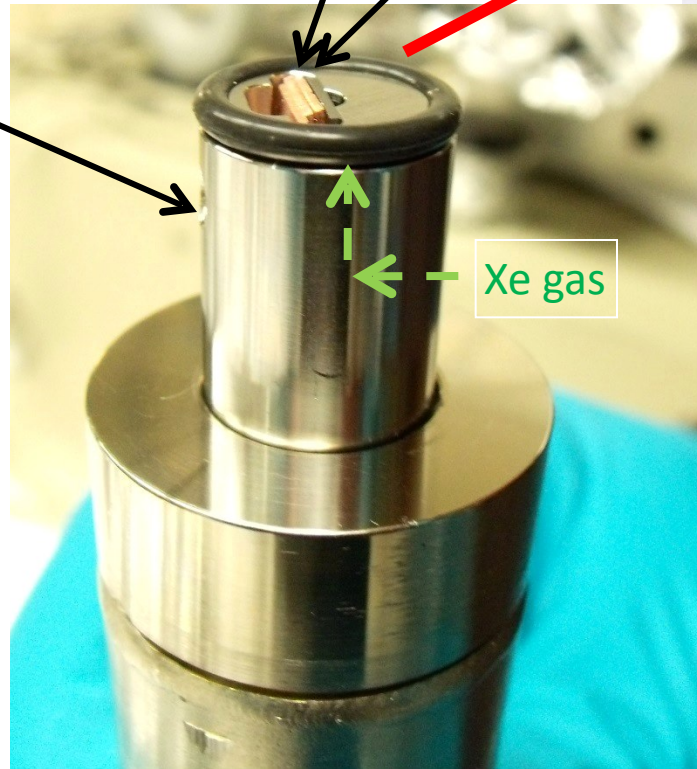
Source holder with dummy (non-plated) source or real source

- Electroplating of ^{148}Gd onto a 0.250" x 0.375" SS plate
- Evaporate BaF (~10 nm) onto ^{148}Gd source
- ^{148}Gd activity before BaF coating ~250 Bq
- Source holder to source gap of ~0.03"

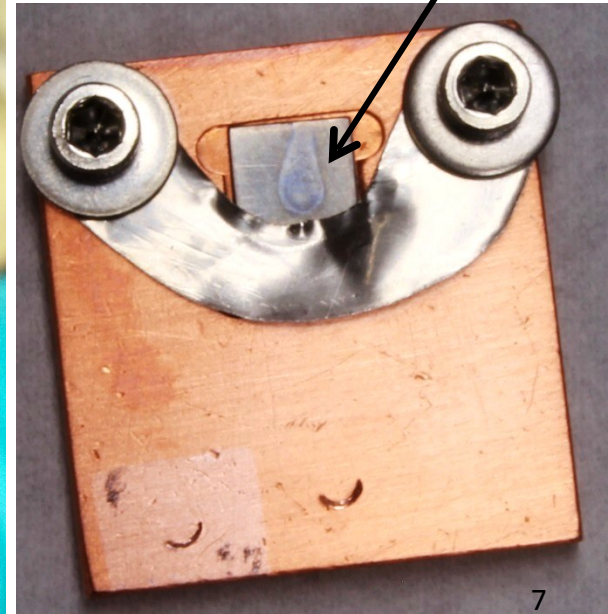


Rev. Sci. Inst. **81** 113301 (2010)

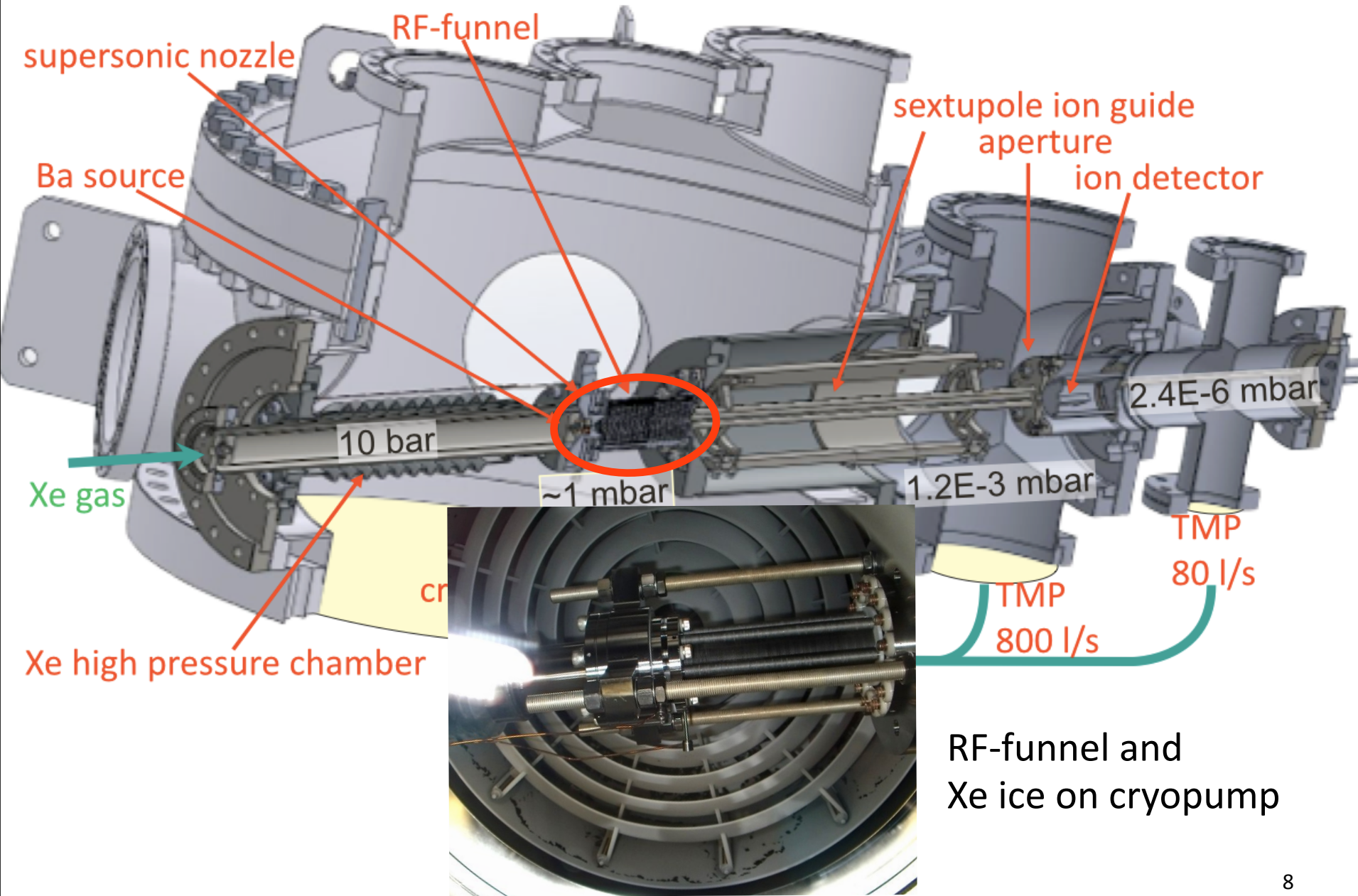
Set screw



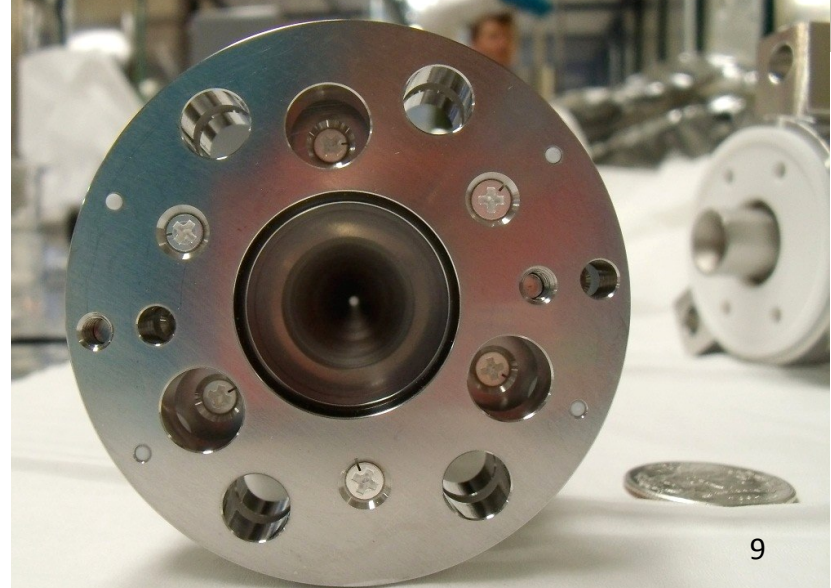
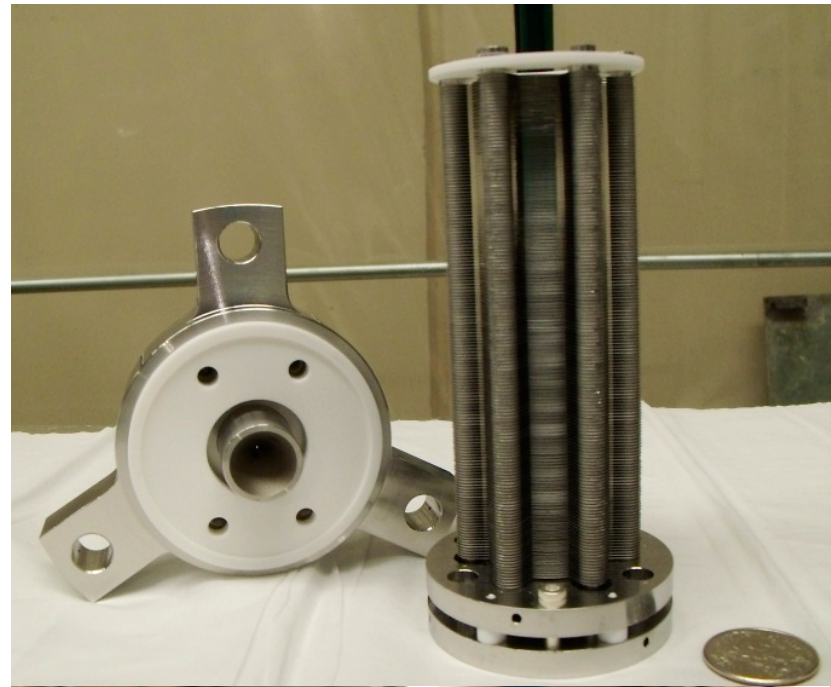
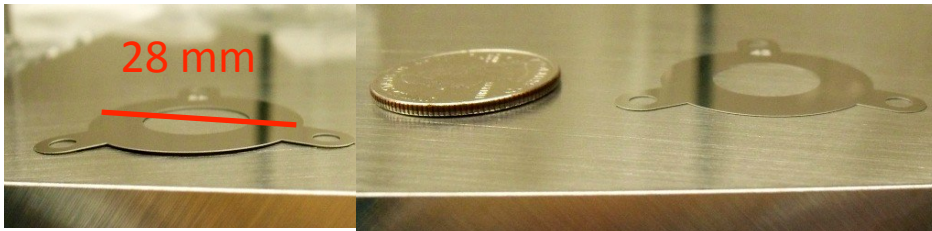
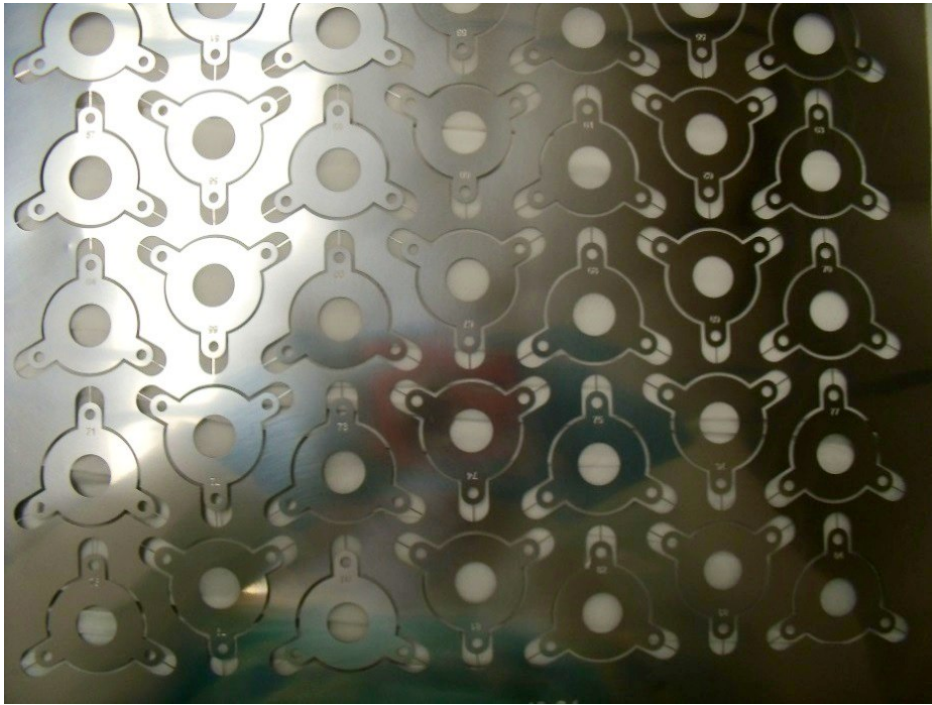
Source



RF-funnel

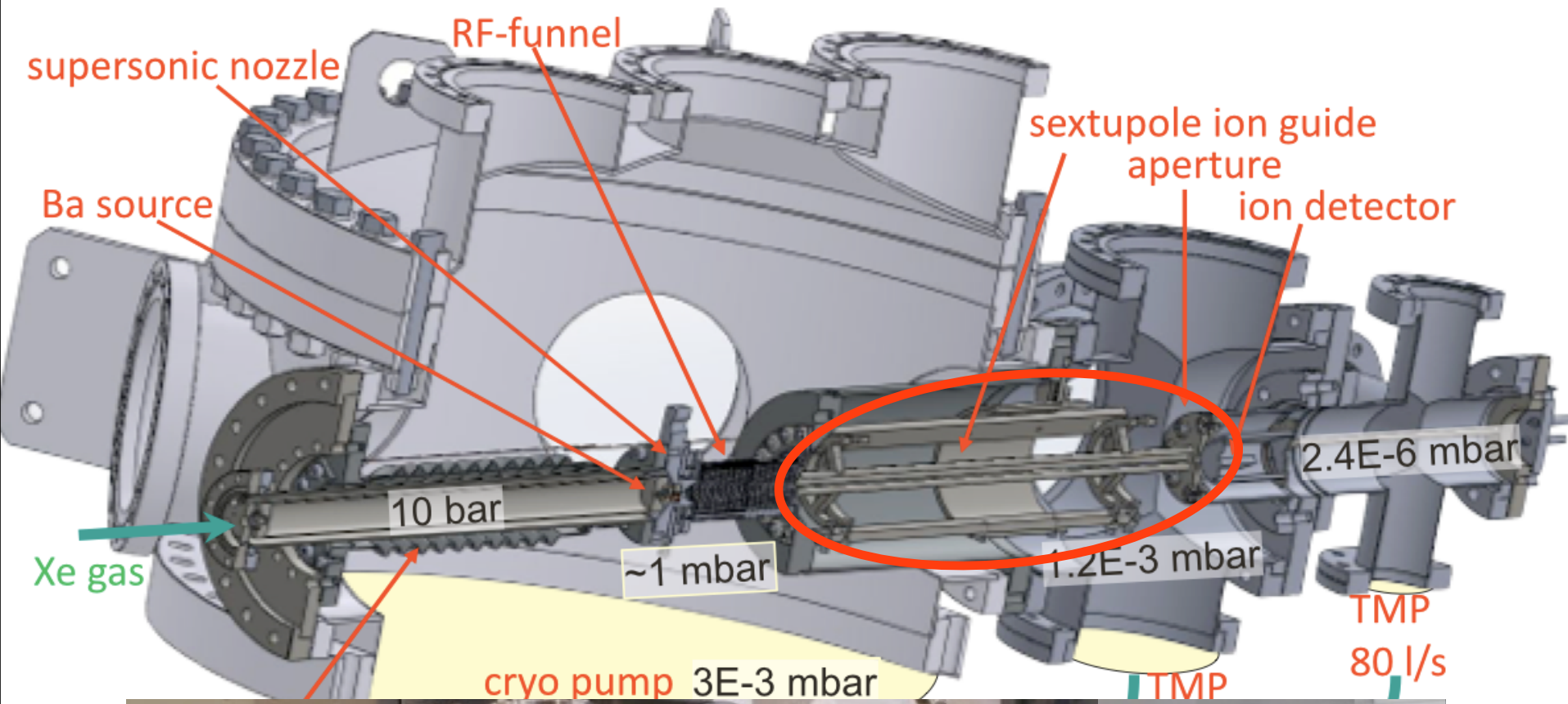


RF-funnel Assembly



- 336 (301 + spares) photo-etched electrodes by Newcut
- 6x7 electrodes/sheet @ 8 sheets
- Metal sheet: 0.1016 mm (± 0.00254 mm)

Downstream Ion Optics

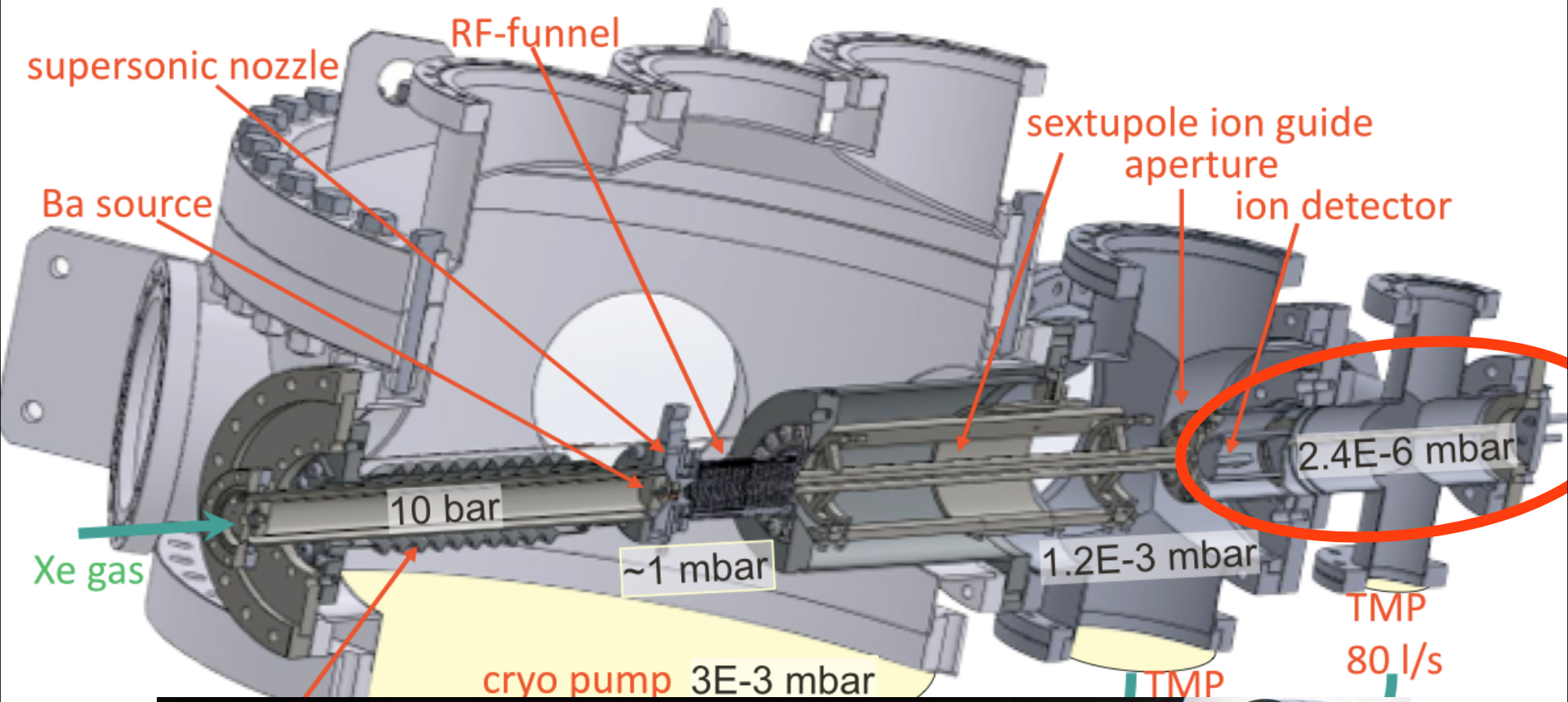


Xe high

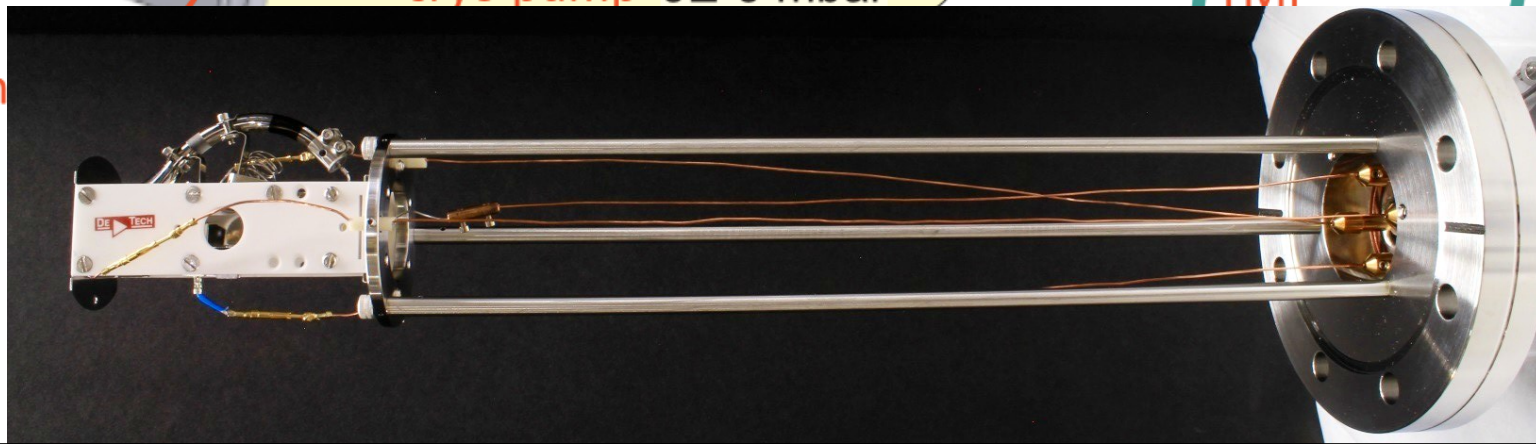
3/16" diameter rods



Ion Detection

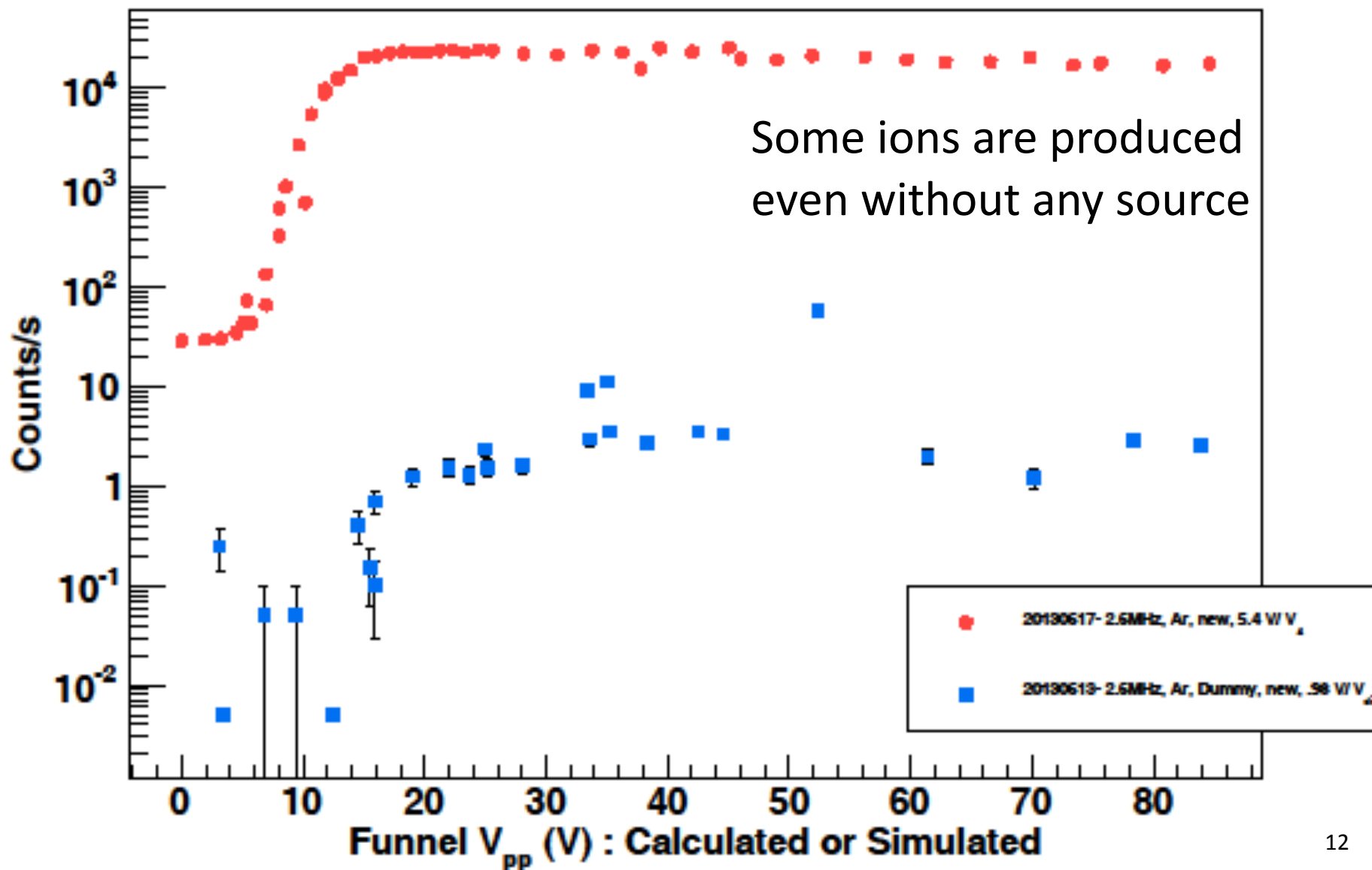


Xe high



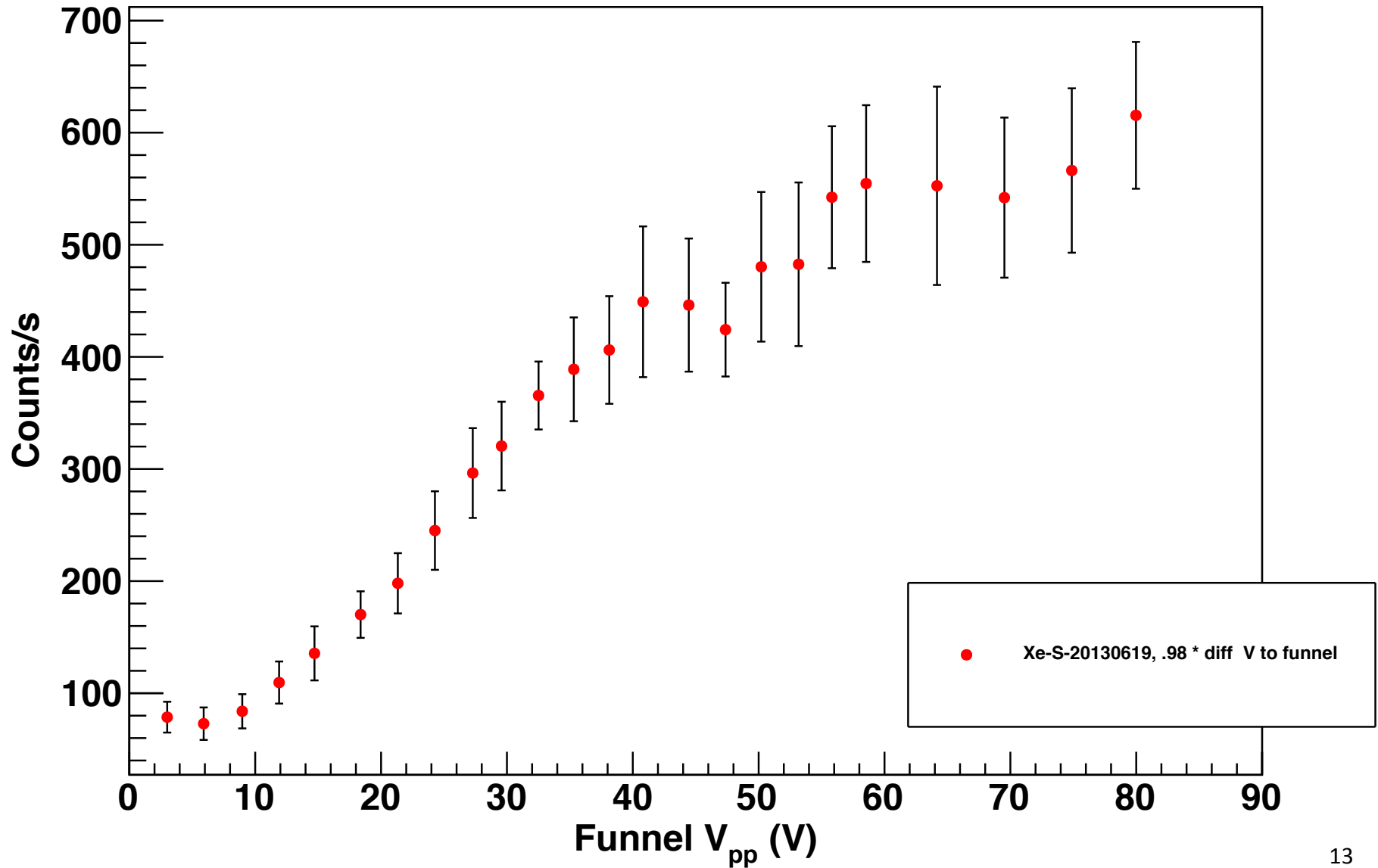
Dummy source vs. Ba⁺ source in Ar

cps in Ar, new amp



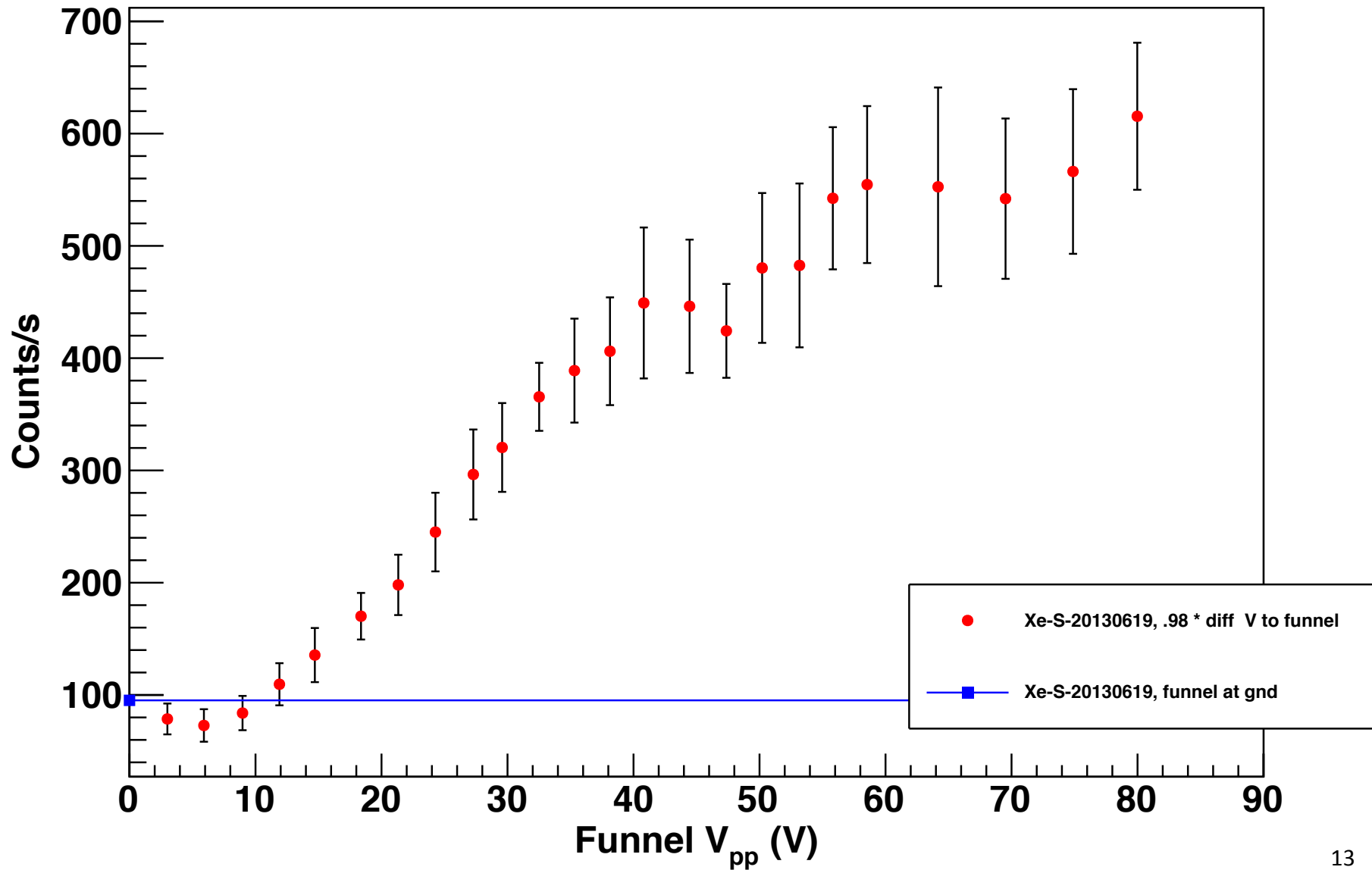
Xe gas operation

Xe-S : cps at 2.6MHz vs V_{pp} on funnel



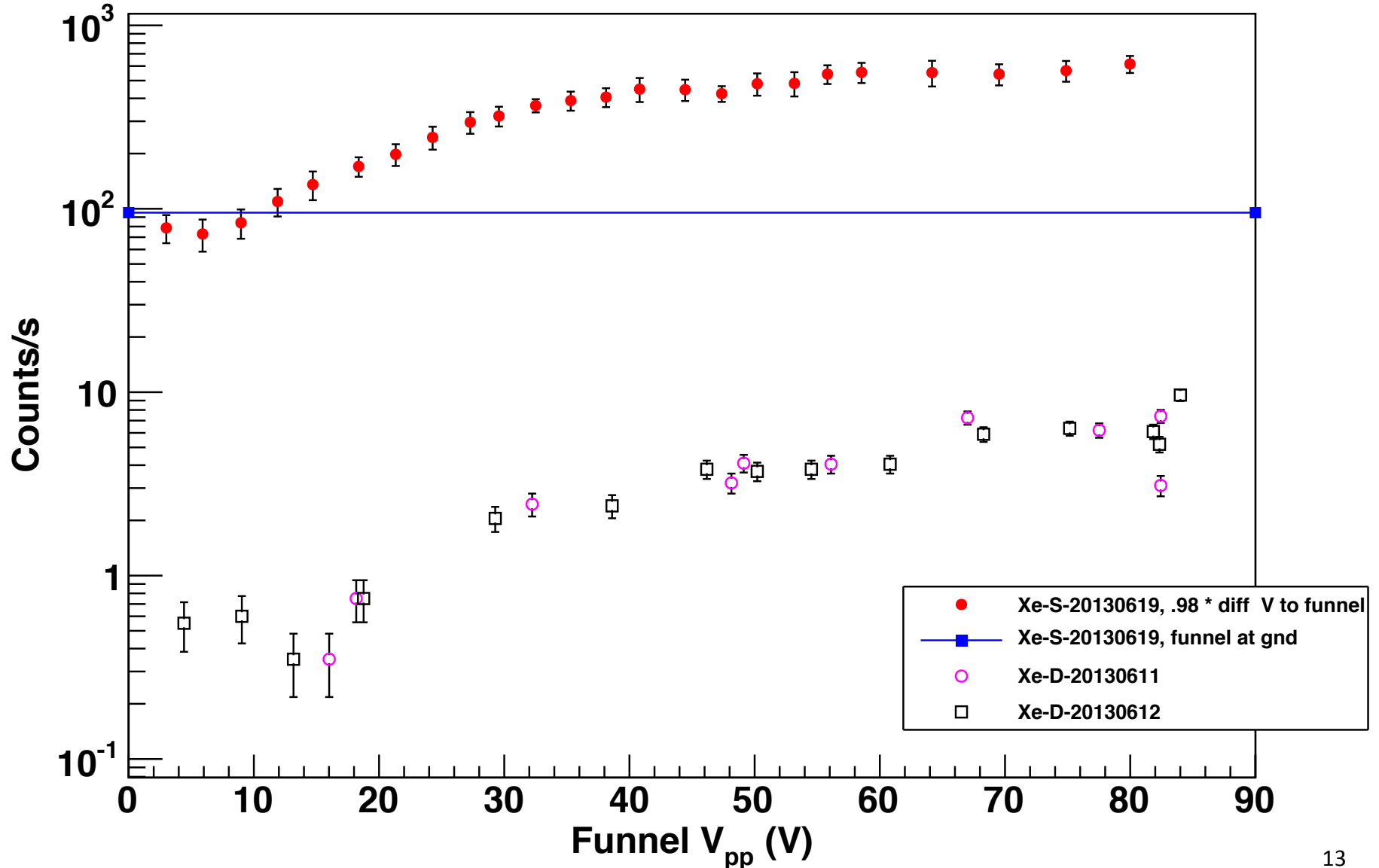
Xe gas operation

Xe-S : cps at 2.6MHz vs V_{pp} on funnel



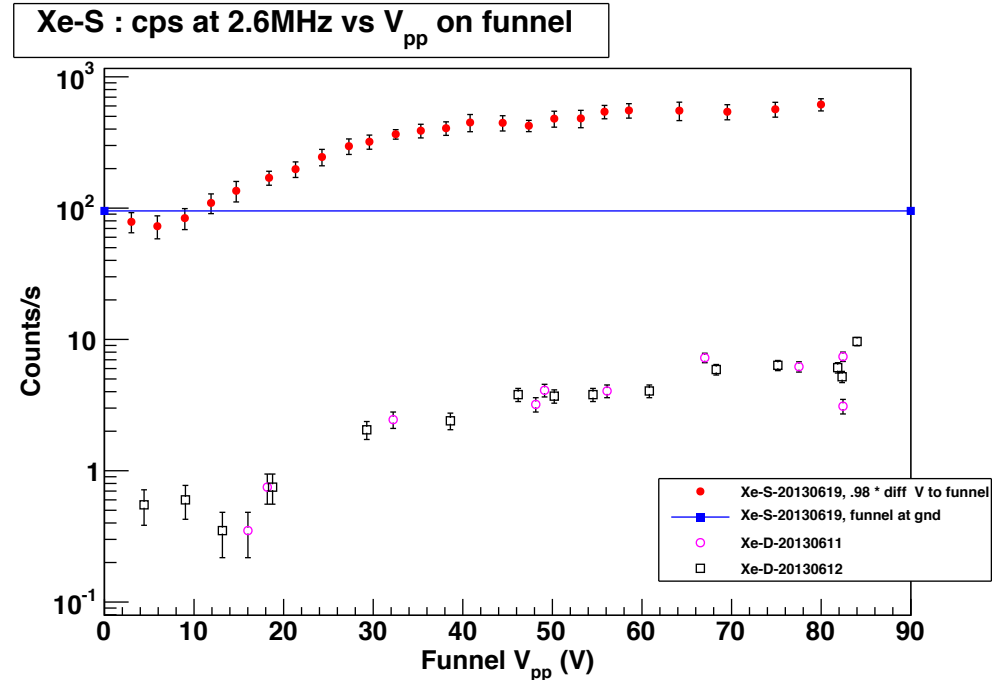
Xe gas operation

Xe-S : cps at 2.6MHz vs V_{pp} on funnel



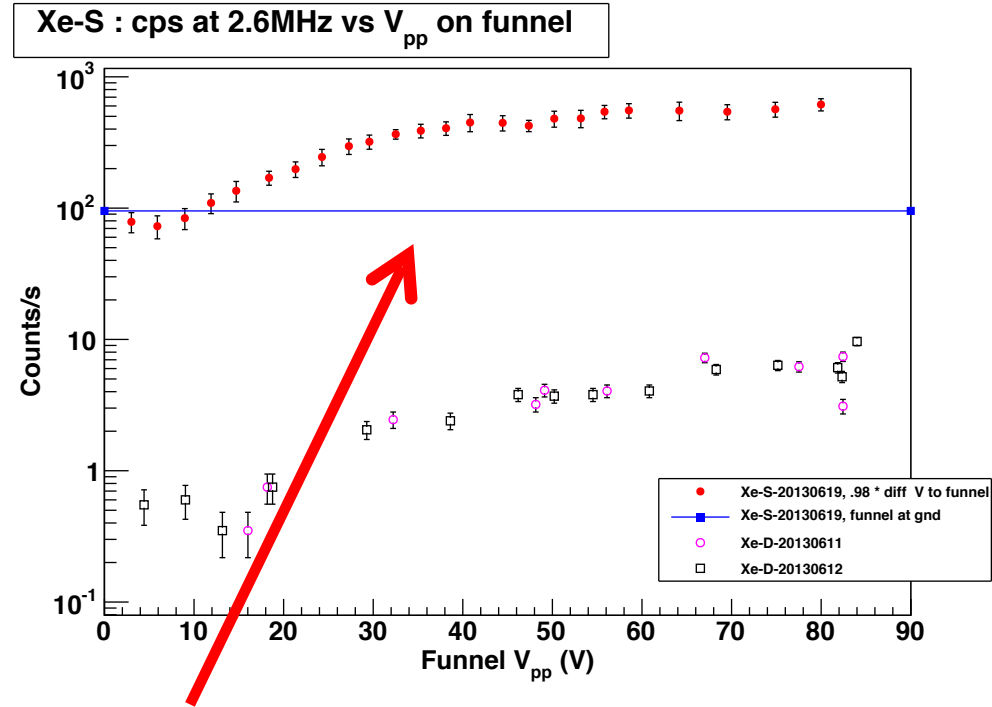
What are we seeing?

- Ions are produced in the gas jet (w/o source)
- Gas jet produced ions respond to RF on funnel the same as ions from source
- w/o RF on funnel, the gas still transports ions
- SPIG guides ions through the differential pumping stage (off -> no counts)
- Ions can be trapped in SPIG



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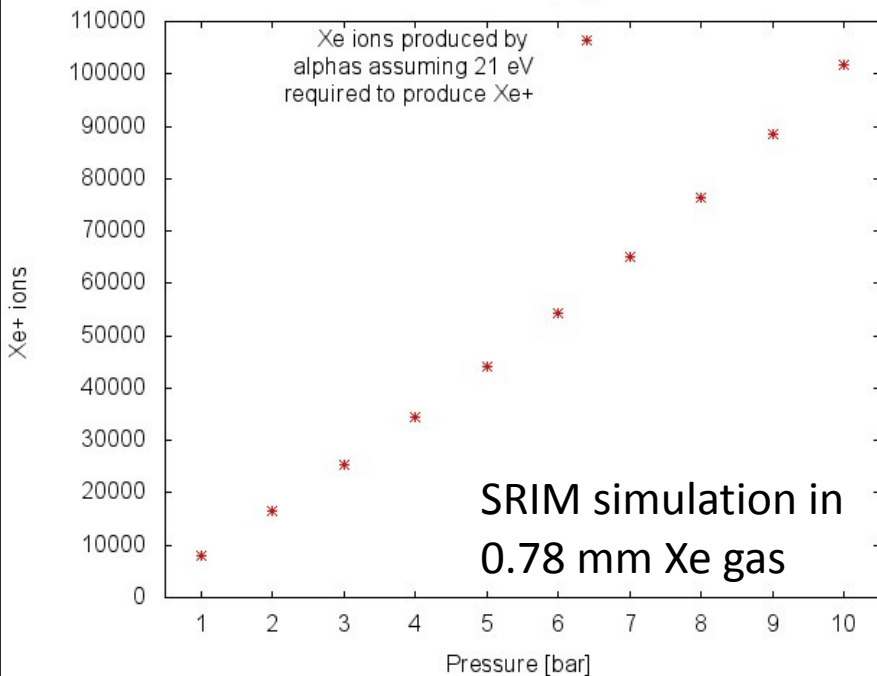
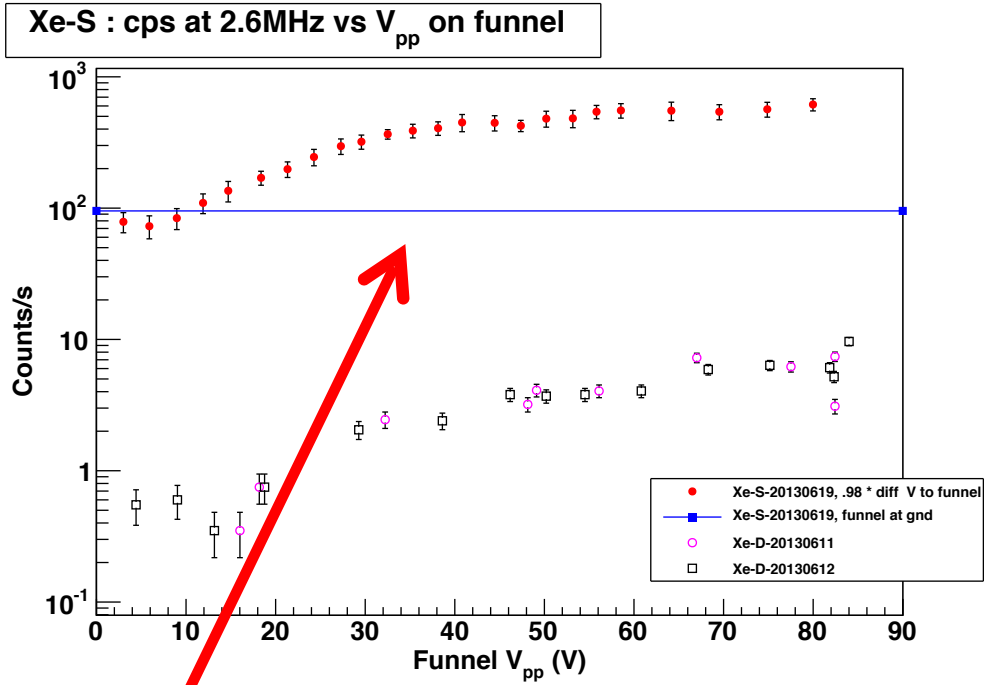
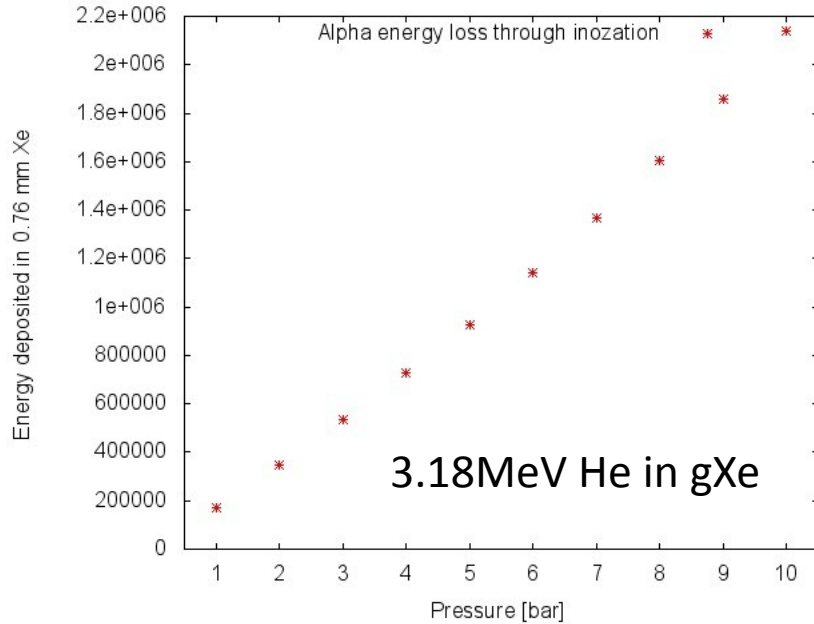
Gedankenexperiment:

With no RF, neutral & ion transport should be the same, measured ~ 90 cps on CEM.

Assuming a gas flow reduction factor of ~ 120 into C over B, this required about 10800 ions in the jet (neglecting SPIG and detection efficiency)

Assuming 60% efficiency -> **18k-ions/s** in funnel with Ba^+ source

What are we seeing?



Gedankenexperiment:

With no RF, neutral & ion transport should be the same, measured on CEM.

Assuming a gas flow rate of 1000 and a collection factor of ~ 120 into CEM, the number of ions required about

10800 ions/s in the jet (neglecting SPIG and detector efficiency)

Assuming 60% efficiency -> **18k-ions/s** in funnel with Ba^+ source

Preliminary

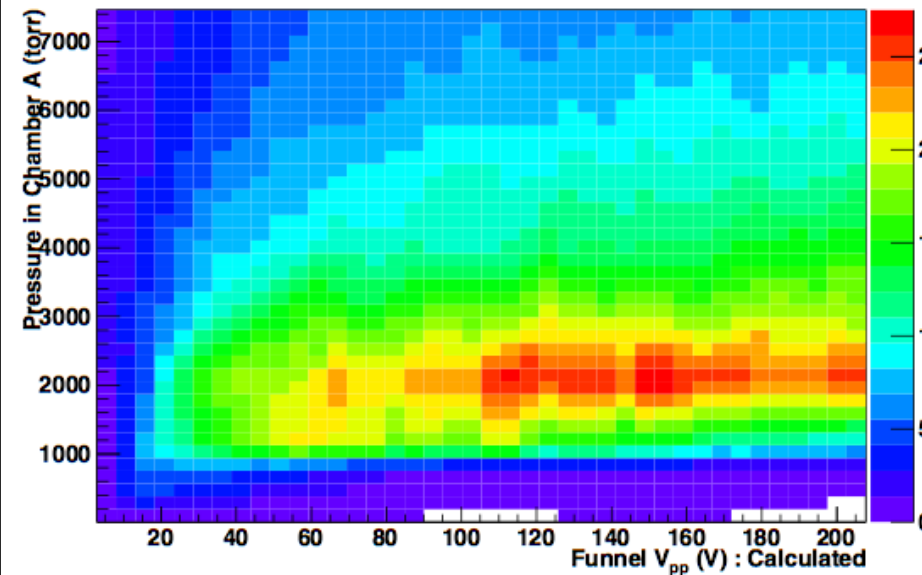
Another Gedankenexperiment

- Xe flow is about 0.34 g/s $\rightarrow 1.5 \times 10^{21}$ atoms/s
- Extraction of 600 ions/s is a reduction of 1800m
- Assuming 2 Ba⁺ ions out of these 600
 \rightarrow only a reduction of 300 left ;-)

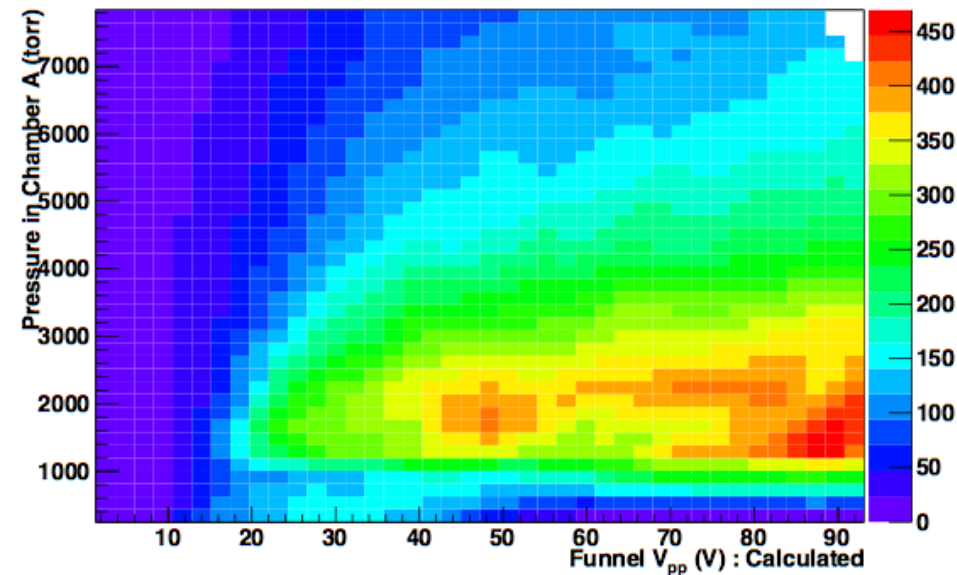
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20130801-Xe-S at 1MHz, Counts vs Pressure and V_{pp}



20130731-Xenon with Source at 2.6 MHz, Counts vs Pressure and V_{pp}



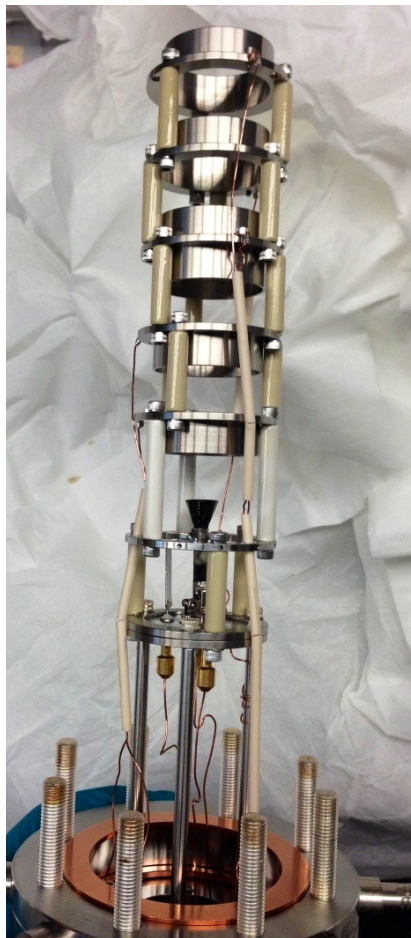
Ion identification - RGA

Idea: Inject ion beam into a commercial RGA unit & scan

Channeltron



Channeltron with lenses



MKS MicroVision 2
RGA with lenses



Signal:

- Detect ions directly
- Focus ions with lens system
- Steer ions with split Einzel lens through an aperture

No signal:

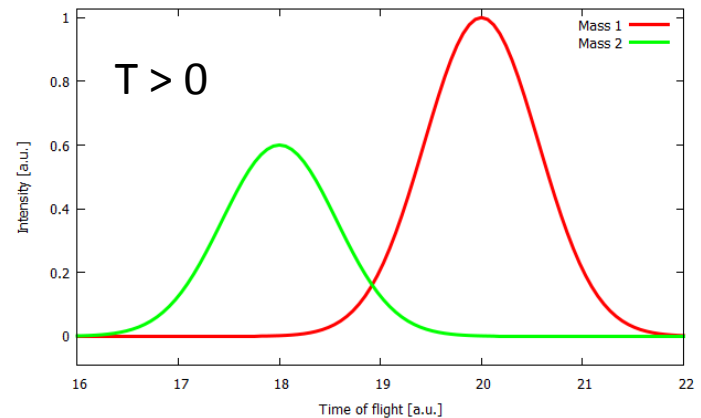
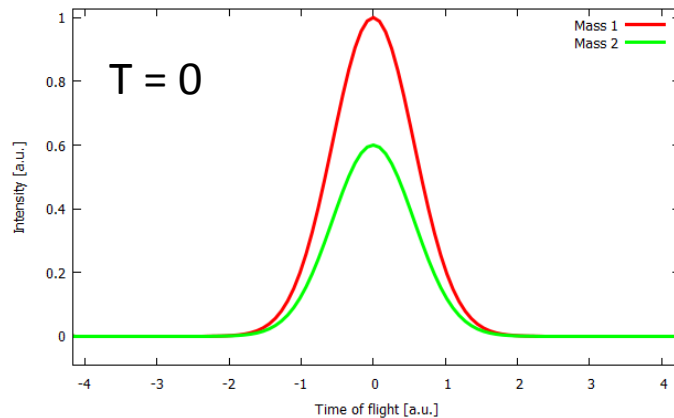
- Ions injected into MV2

Thanks to MKS for
lending us a MV2 unit

Ion identification – ToF mass spectrometry

$E_{\text{kin}} = \frac{1}{2} m v^2 \rightarrow$ all ions start with same E_{kin}

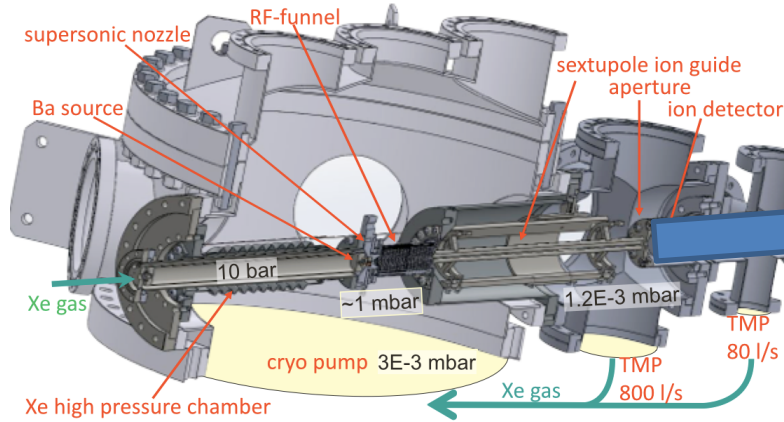
$\rightarrow m/q$ determination by ToF



ToF MS in ES3 for Ba tagging

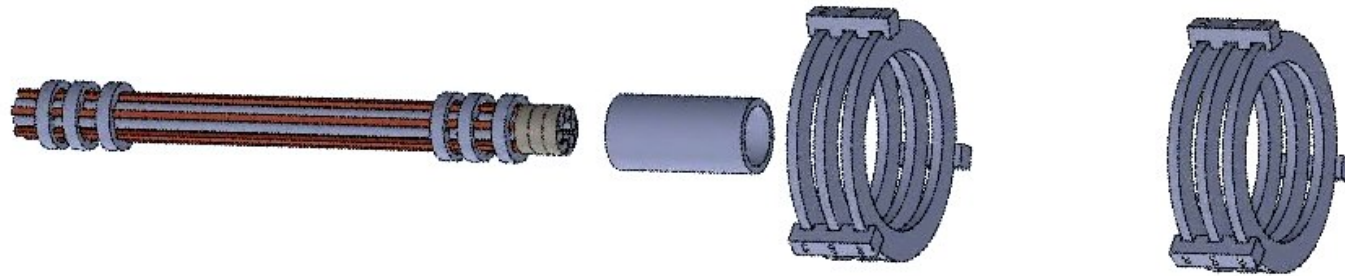
1. Capture DC ion beam and cool ions (in linear Paul trap)
2. Extract a short ion bunch
3. Adjust kinetic energy of ions inside the bunch
4. Find m/q of ions in bunch by recording time of flight to an ion detector

MR TOF MS



m/q identification

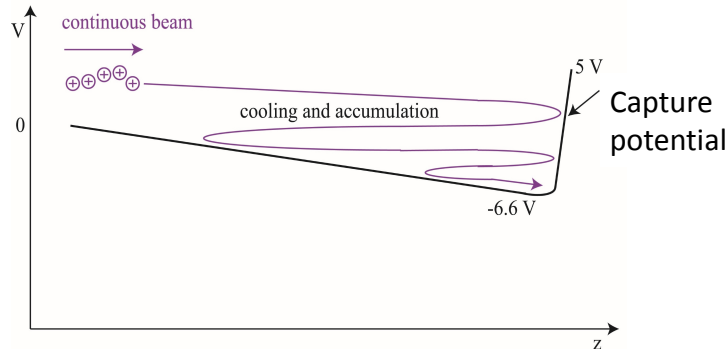
- SPIG with coupled DC electrodes
- He buffer gas ion cooling
- Pulsed drift tube (PDT) to adjust energy
- Electrostatic mirrors for ToF



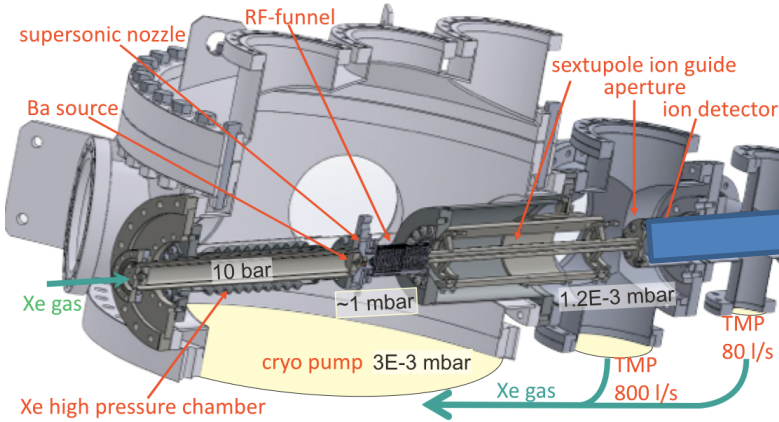
Linear Paul trap

PDT

Switchable electrostatic mirrors

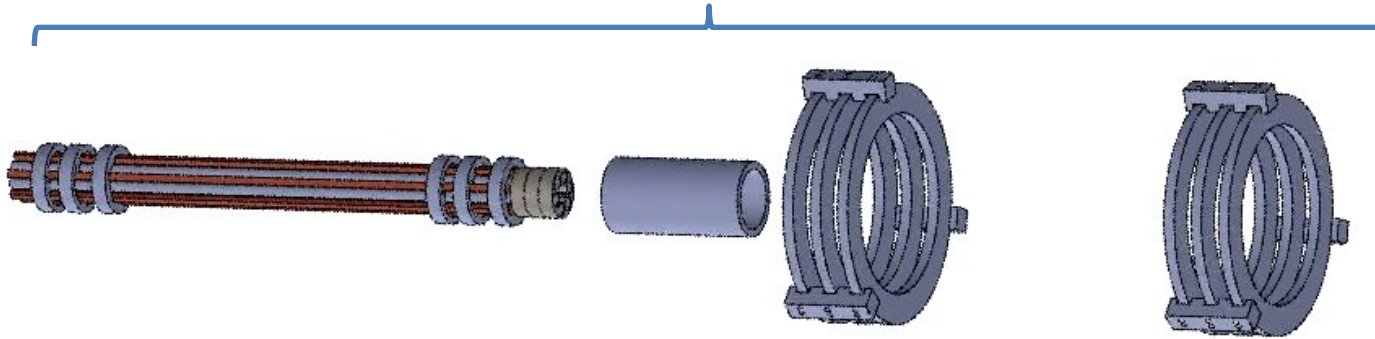


MR TOF MS



m/q identification

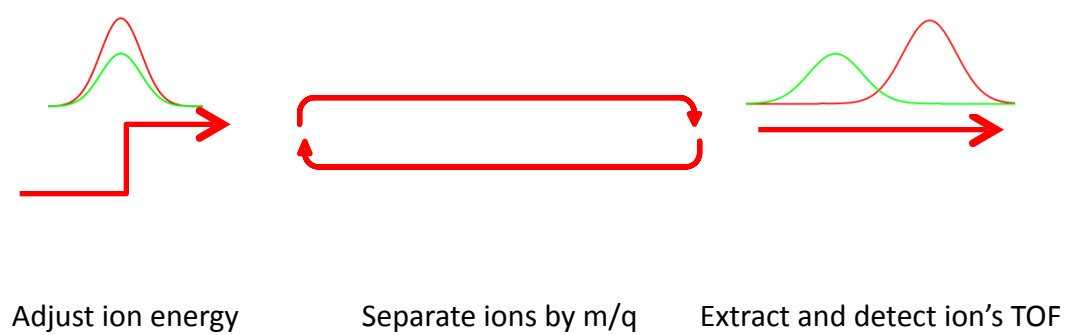
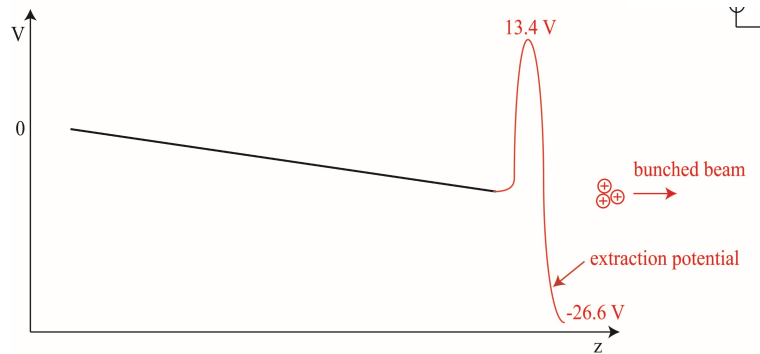
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Linear Paul trap

PDT

Switchable electrostatic mirrors



Next Steps – Stay Tuned

Fabricate ion source with new ion source design (0.010" gap)

Determine means to identify ions by q/m -> design a multi-reflection TOF mass spectrometer

Determine the possibilities to measure Ba^{++} source activity

Determine efficiency of funnel

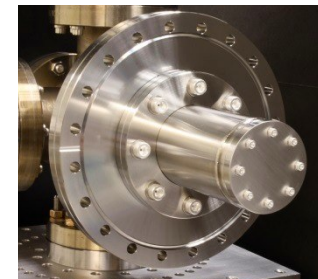
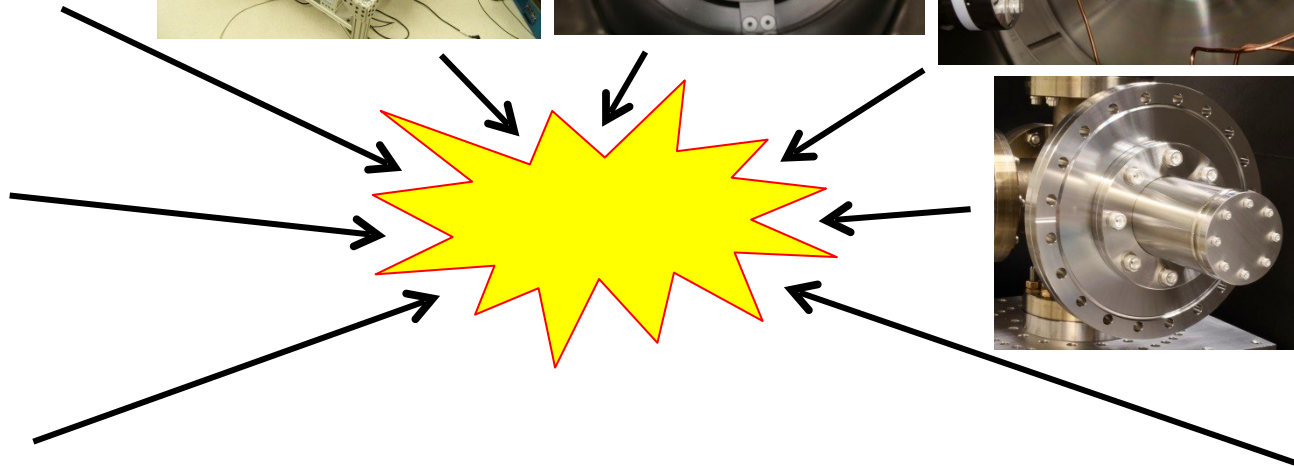
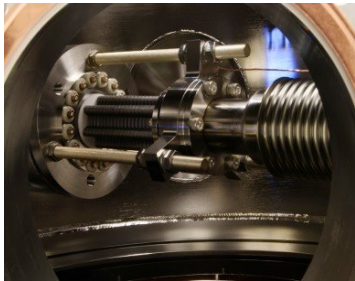
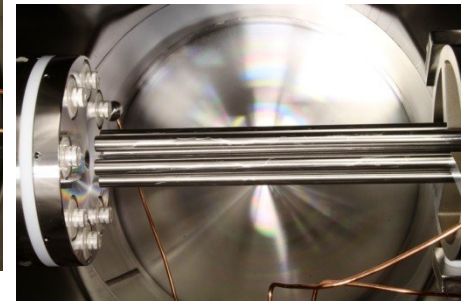
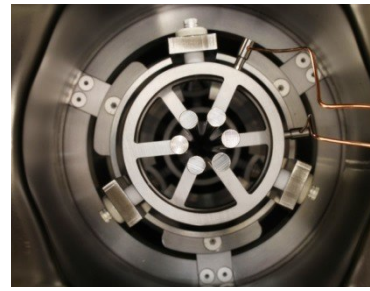
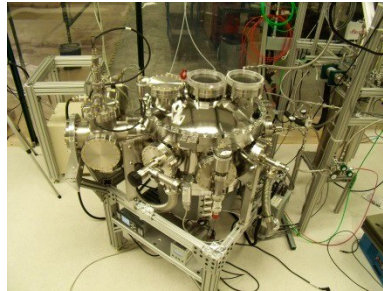
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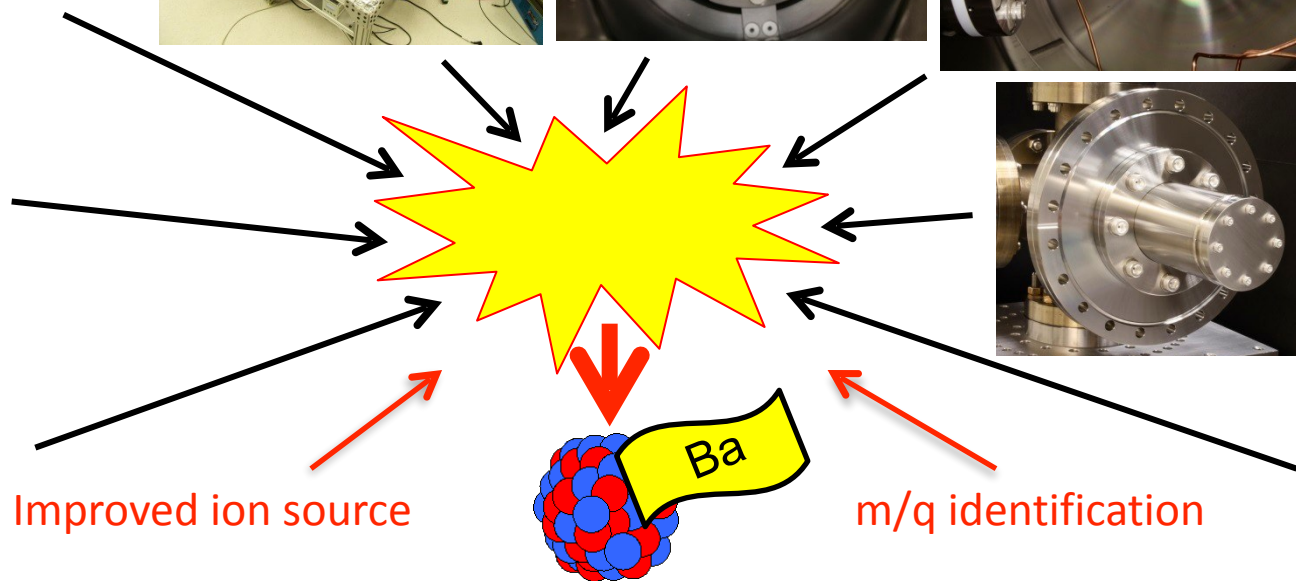
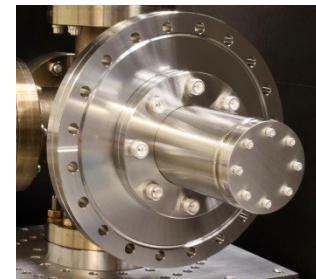
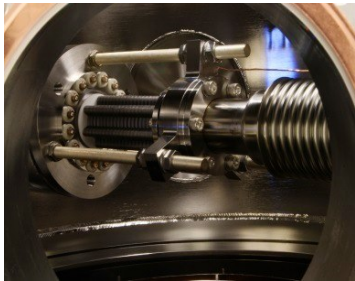
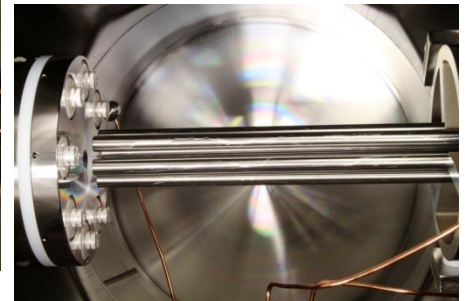
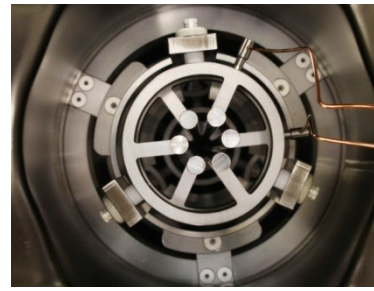
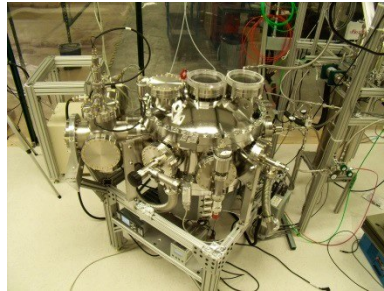
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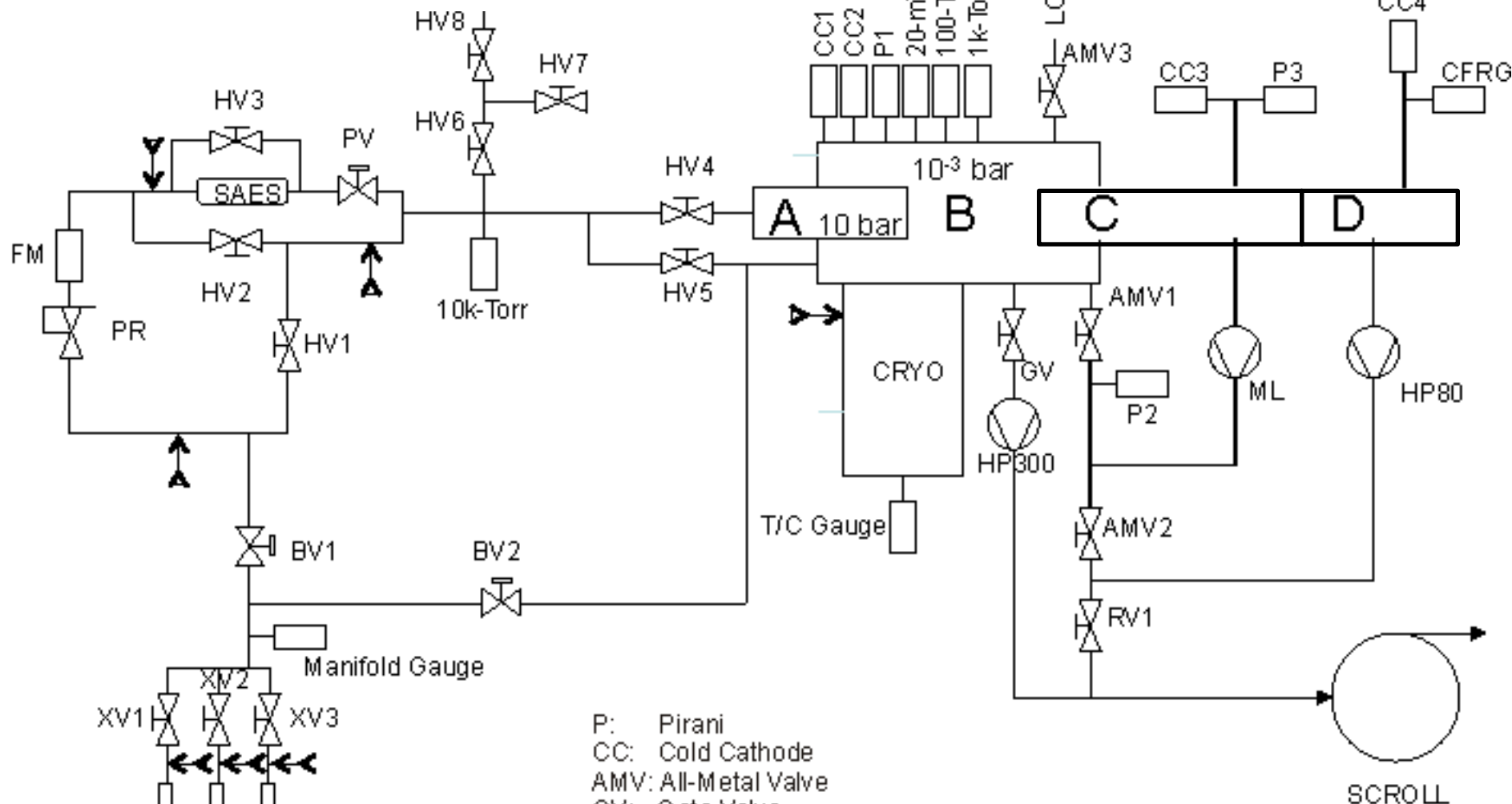


Improved ion source

m/q identification

Backup slides

Argon Line + Purifier



- P: Pirani
- CC: Cold Cathode
- AMV: All-Metal Valve
- GV: Gate Valve
- HV: Hand Valve
- PR: Pressure Regulator
- FM: Flow Meter
- BV: Block Valve (pneumatic)
- ML: MagLev
- HP: HiPace
- RV: Roughing Valve
- LC: Leak Check
- CFRG: Compact Full Range Gauge

**Maximum flow manageable
by CryoPump: 0.5 g/s
Xe can be recovered into
the gas bottles**

Funnel Parameters

Converging-diverging nozzle

Half-angle of subsonic cone

45°

Half-angle of supersonic cone

26.6°

Throat diameter

0.28 mm

Mass Flow

0.33 g/s

Exit diameter

16.0 mm

Subsonic part length

0.5 mm

Supersonic part length

15.5 mm

RF-funnel electrodes

Entrance aperture diameter

CU

0.6299"

Exit aperture diameter

0.0394"

Ring electrode diameter

1.1024"

Change in aperture diam./el.

0.0020"

Ring electrode thickness

0.0040"

(design)

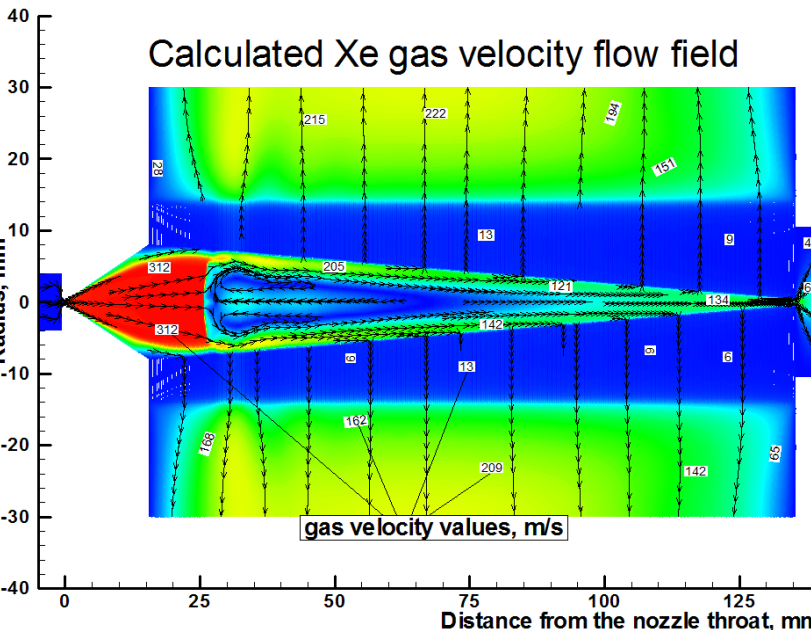
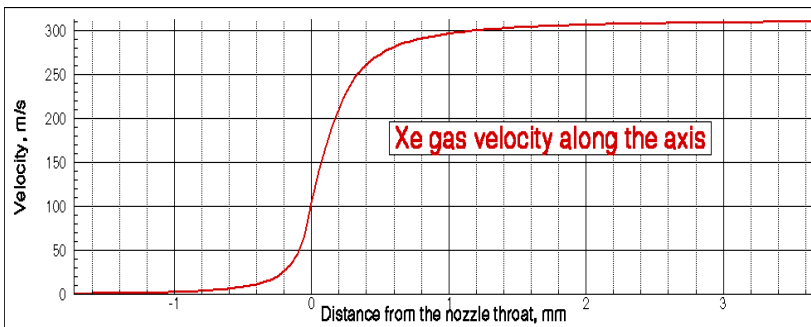
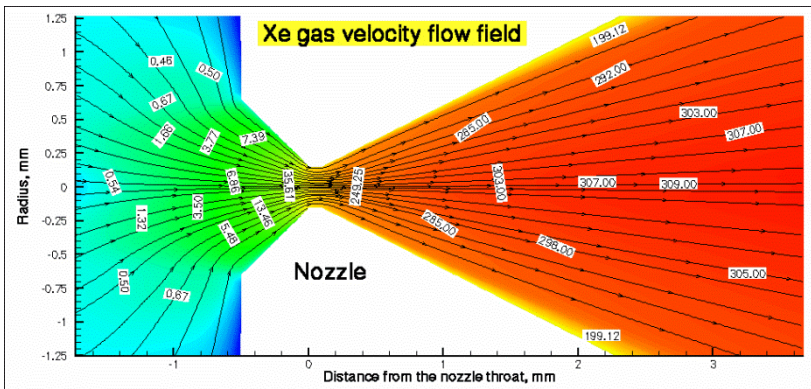
0.0001"

Gap between electrodes

0.0100"

Total number of electrodes

301



Simulated Efficiencies

Victor's funnel @ 2.6 MHz	72.0%
Sextupole ion guide	91.2%
Aperture to CEM	83%
CEM efficiency	80%
TOTAL	44%